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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EXHIBIT APPLICATION OF:

Jin JANG et al.

ART UNIT: 2814

APPLICATION NO.: 09/497,508

EXAMINER: W. Louie

FILING DATE: February 4, 2000

FOR: POLYCRYSTALLINE SILICON FILM CONTAINING Ni

AMENDMENT

Commissioner of Patents  
Washington, D.C. 20231

Sir:

In response to the Official Action dated May 21, 2001, the time for which response has been extended three months to November 21, 2001, the following amendments and remarks are respectfully requested.

IN THE SPECIFICATION:

Please **AMEND** the specification as shown in Exhibit I, which is a marked up version of the amended specification. A Substitute Specification is being attached with this Amendment. No new matter has been added by the Substitute Specification.

RECEIVED  
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TECHNOLOGY CENTER 2800